Physical Vapor Deposition Plus

- Multi-ports electro-polished UHV stainless steel vacuum chamber
- Electron beam, Pulsed laser Deposition, Thermal evaporation, Sputtering, CVD
- Independent substrate heater and optimal rotation
- Mass flow controllers of various ranges
- Standard pressure gauges
- Mechanical and Cryo, Turbo vacuum pump
- Optional stainless steel load lock chamber
- Optional motorized control of substrate to source distance
- Excellent tool for nano and thin film metal-oxides, nitrides, carbides, metals and Multilayer/Superlattices
- Add and Integrate Graphene CVD Process

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